

03560.002998.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
YUKIKO IWASAKI ET AL.)	Examiner: Asok K. Sarkar
Application No.: 10/083,585)	Group Art Unit: 2829
Filed: February 27, 2002)	
For: METHOD FOR)	
MANUFACTURING A)	
SEMICONDUCTOR FILM)	August 26, 2003

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AUG 27 2003
TECHNOLOGY CENTER 2000

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action dated May 27, 2003, please amend the
above-identified application as follows.

10/07/2003 AMISE: 00000010 051201 00000000
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